

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/537,952 Confirmation No. 1520
Applicant : Joseph M. AMATO
Filed : June 8, 2005
TC/A.U. : 2829
Examiner : Tung X. Nguyen

Docket No. : **US02 0574 US**
Customer No. : 65913

Title: RESISTOR STRUCTURES TO ELECTRICALLY
MEASURE UNIDIRECTIONAL MISALIGNMENT OF
STITCHED MASKS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE & AMENDMENT AFTER NOTICE OF ALLOWANCE

Sir:

In response to the Notice of Allowance dated May 16, 2008, please consider the following. Examiner had noted defects in the Oath & Declaration. Applicant has included a replacement Oath & Declaration along with the Issue Fee Payment.

Amendments to the Specification there are no amendments this paper.

Amendments to the Claims there are no amendments in this paper.

Remarks/Arguments begin on page 2 of this paper. A replacement Oath & Declaration follows.